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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of Applicants:

Beaman et al.

Serial No.: 09/251,988

Filed: February 17, 1999

Date: May 15, 2002

Group Art Unit: 2829

Examiner: J. M. Hollington

Docket No.: YO999-088

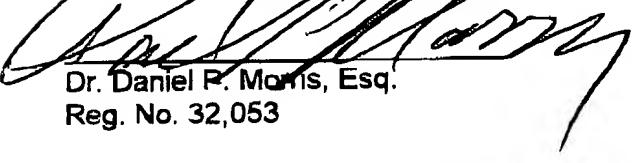
For: STRUCTURAL DESIGN AND PROCESSES TO CONTROL PROBE  
POSITION ACCURACY IN A WAFER TEST PROBE ASSEMBLY ~~FAX COPY RECEIVED~~Assistant Commissioner for Patents  
Washington, D. C. 20231

MAY 15 2002

## CERTIFICATE OF FACSIMILE TRANSMISSION

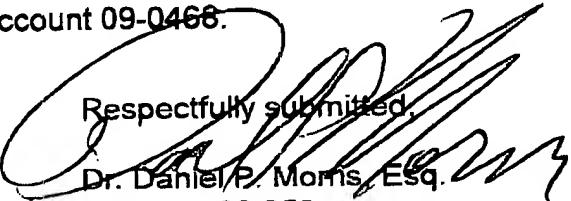
TECHNOLOGY CENTER 2800

I hereby certify that this Information Disclosure Statement Transmittal Letter and PTO-1449 Form with three (3) US References (33 Total Pages) are being facsimile transmitted under Rule 37 CFR 1.61(d) to the U.S. Patent and Trademark Office to (703) 308-7722 on May 15, 2002.

Dr. Daniel P. Morris, Esq.  
Reg. No. 32,053INFORMATION DISCLOSURE STATEMENT TRANSMITTAL LETTER

Sir:

Please find enclosed a listing (PTO Form 1449) of references which may be relevant to the above-referenced application. This listing of references is not a representation that a search has been made, that better references than listed do not exist, or that other references are not applicable. Moreover, this listing does not constitute any admission by applicants or applicants' attorney that the information provided herein is necessarily prior art to applicants' invention. Please charge any fee necessary to enter this paper to deposit account 09-0468.



Respectfully submitted,

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